

## **ABSTRACT**

According to an example embodiment of the present invention a semiconductor die having a resistive electrical connection is analyzed. Heat is directed to the die as the die is undergoing a state-changing operation to cause a failure due to suspect circuitry.

The die is monitored, and a circuit path that electrically changes in response to the heat is detected and used to detect that a particular portion therein of the circuit is resistive.

In this manner, the detection and localization of a semiconductor die defect that includes a resistive portion of a circuit path is enhanced.